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Docket No. 47513CPA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**APPLICANT:** Peter W. J. Jones      **EXAMINER:** T. Nguyen  
**SERIAL NO.:** 09/094,052      **GROUP:** 2872  
**FILED:** June 9, 1998

**FOR:** METHODS FOR REFLECTION REDUCTION

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CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Assistant Commissioner for Patents, Washington, D.C. 20231 on February 8, 2001.

Annemarie Serrechia  
Annemarie Serrechia

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, DC 20231

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**RESPONSE TO OFFICE ACTION**

Sir:

The following is in response to the Office Action mailed August 15, 2000 in the above referenced application.

Please amend the subject application as follows:

IN THE CLAIMS:

1. (Three times amended) An apparatus for reducing reflection on a surface comprising:  
a plurality of concentric circular vanes, mounted in front of said reflective surface, each of said vanes including a first end proximate said surface, and a second end away from said surface, wherein said first ends of said plurality of vanes are spaced apart from each other at a different distance than said second ends of said plurality of vanes are spaced apart from each other, and wherein said first ends of said

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